



Docket No. 740819-1030
Serial No. 10/679,464
Page 1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Kenshi KANEGAE et al.) Group Art Unit: 1765
Serial No. 10/679,464) Examiner: Kin-Chan Chen
Filed: 10/7/2003) Confirmation No. 5297
For: ETCHING METHOD,) Date: November 20, 2006
SEMICONDUCTOR AND)
FABRICATING METHOD FOR THE)
SAME)

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Signature: _____

Name: Jeannie Saxton

AMENDMENT

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 18, 2006, please amend the above-identified application as follows.